Docket No.: SON-2129/DIV

(80001-2910) (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Divisional Patent Application of U.S.

Examiner: J. Nguyen

Application No.: 09/883,235

Tsuyoshi TOJO, et al.

Art Unit: 2815

Application No.: Not Yet Assigned

Filed: November 25, 2003

For: SEMICONDUCTOR LASER

CLAIM FOR PRIORITY AND SUBMISSION OF DOCUMENTS

MS PATENT APPLICATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The benefit of the filing dates of the following prior applications filed in the following foreign country is hereby requested and the right of priority provided under 35 U.S.C. §119 is hereby claimed:

Japanese Patent Appl. No. P2000-183920, filed June 20, 2000 Japanese Patent Appl. No. P2000-207229, filed July 7, 2000

In support of this claim, filed within parent application Serial No. 09/883,235 is a certified copy of said original foreign applications.

Dated: November 25, 2003

Respectfully submitted,

Ronald P. Kananen

Registration No.: 24,104

Attorney for Applicant

RADER, FISHMAN & GRAUER PLLC

1233 20th Street, N.W. Suite 501

Washington, D.C. 20036

Tel: (202) 955-3750 Fax: (202) 955-3751 Customer No. 23353

DC139444